

SiO₂ 基板上のグラフェンフィルム(野田教授_早稲田大学)の関連論文

1. Direct synthesis of few-and multi-layer graphene films on dielectric substrates by “etching-precipitation” method, M. Kosaka, et al., Carbon 82 (2015) 254.
2. Direct formation of continuous multilayer graphene films with controllable thickness on dielectric substrates, S. Akiba, et al., Thin Solid Films 675 (2019) 136.
3. High-speed and on-chip graphene blackbody emitters for optical communications by remote heat transfer, Y. Miyoshi, et al., Nat. Commun. 9 (2018) 1279.